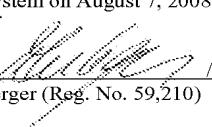


IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s) : Aaron Partidge et al.
 Serial No. : 10/713,172
 Filing Date : November 14, 2003
 For : **CRACK AND RESIDUE FREE CONFORMAL
DEPOSITED SILICON OXIDE WITH
PREDICTABLE AND UNIFORM ETCHING
CHARACTERISTICS**
 Group Art Unit : 1792
 Examiner : Francis P. Smith
 Confirmation No. : 9823
Customer No. : **26646**

Mail Stop Amendment
 Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

I hereby certify that this correspondence is being electronically transmitted to the United States Patent and Trademark Office via the Office electronic filing system on August 7, 2008.

Signature: / 
 Aaron Grunberger (Reg. No. 59,210)

RESPONSE TO RESTRICTION REQUIREMENT

SIR:

This response addresses the restriction requirement dated July 14, 2008, the one-month response date for which is August 14, 2008.

Remarks begin on page 2 of this paper.

While no fee is believed to be due, the Commissioner is authorized, as appropriate and/or necessary, to charge any fees (including any Rule 136(a) extension fees) or credit any overpayment to Deposit Account No. **11-0600 of Kenyon & Kenyon LLP**.